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Application Number	10/553,326
Filing Date	October 14, 2005
First Named Inventor	Liang-Chy Ghien
Art Unit	2871
Examiner Name	Tai V. Duong
Attorney Docket Number	KENT-B-PCT-US

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue numbers(s), publisher, city and/or country where published.	T ²
/T.D./		O. Yaroshchuk, Yu. Zakrevskyy, A. Dobrovolskyy, S. Pavlov, <i>Liquid Crystal Alignment on the Polymer Substrates Irradiated by Plasma Beam</i> . Proc. of SPIE, Vol. 4418, 49-53 (2001). No month provided.	x
/T.D./		O. Yaroshchuk, Yu. Zakrevskyy, A. Dobrovolskyy, S. Pavlov, <i>Polymer Films Treated with Plasma Beam as Aligning Substrates for Liquid Crystals</i> , Asia Display/IDW, 73-76 (2001). No month provided.	x
/T.D./		O. Yaroshchuk, R. Kravchuk, A. Dobrovolskyy, S. Pavlov, <i>P-14: Plasma Treatment as a Method of In-Plane LC Alignment</i> , Eurodisplay, 421-424 (2002). No month provided.	x

Examiner Signature	/Tai Duong/	Date Considered	11/21/2009
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